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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of:

Hindrik Willem De Vries

Appl. S.N.: 10/584,075

Filing Date: 07-16-2008

Title: Method of and Arrangement for Removing
Contaminants from a Substrate Surface Using
an Atmospheric Pressure Glow Plasma

Confirmation No.: 8763

Attorney Docket: 2602-0011

Group Art Unit: 2821

Examiner: ALEMU, EPHREM

Date: August 25, 2010

AMENDMENT

Hon. Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated May 25, 2010, please amend the application as follows:

Amendments to the claims are reflected in the listing of the claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.

A Terminal Disclaimer is Attached hereto at the end of the Response.